



504-9925

U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM 10001333	FILING DATE 10/26/2001	CLASS 427 250	SUBCLASS 595	GAU 288+	EXAMINER Mceks
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**APPLICANTS: Kaito Takashi;

**CONTINUING DATA VERIFIED:

Abu Name

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** FOREIGN APPLICATIONS VERIFIED:

JAPAN 2000-333368 10/31/2000

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☐ yes ☐ no

35 USC 119 conditions met ☐ yes ☐ no

Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO

S004-4433

TITLE : Beam shaped film pattern formation method

U.S. DEPT. OF COMM./PAT. & TM.-PTO-435L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED		
		Assistant Examiner	Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drwg.	Figs. Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner	
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